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UNITED BYATES DEPARTMENT OF COMMERCE Valued Survey Pacent and Tradester's Office Active Company Fig. 6th 1425 Active Company for PATENTS ACTIVE WILLIAM SUITS IN 1425 MILES ACTIVE WILLIAM SUITS IN 1425 MILES ACTIVE ACTIVE ACTIVE MILES ACTIVE MILES ACTIVE ACTIVE ACTIVE MILES ACTIVE MILES ACTIVE ACTIVE ACTIVE MILES ACTIVE ACTIVE ACTIVE MILES ACTIVE ACTI

BIBDATASHEET

Bib Data Sheet

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APPLICANTS

Mamoru Nakasuji, Kanagawa, JAPAN:

Muneki Hamashima, Saitama, JAPAN:

Nobuharu Noji, Kanagawa, JAPAN;
Tohru Satake, Kanagawa, JAPAN;Masahiro Hatakeyama, Kanagawa, JAPAN;
Kenji Watanaba, Kanagawa, JAPAN;
Takao Kato, Tokyo, JAPAN;
Hirosi Sobukawa, Kanagawa, JAPAN;
Tsutomu Karimata, Kanagawa, JAPAN;
Shoji Yoshikawa, Tokyo, JAPAN;
Toshifumi Kimba, Kanagawa, JAPAN;
Shin Oowada, Kanagawa, JAPAN;
Mutsumi Saito, Kanagawa, JAPAN;

CONTINUING DATA

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• FOREIGN APPLICATIONS ********

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ADDRESS 38834 WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP 1250 CONNECTICUT AVENUE, NW SUITE 700 WASHINGTON, DC 20036								
TITLE Electron beam apparatus and method of manufacturing semiconductor device using the apparatus								
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